


Search Notes 	Application/Control No. 10784979	Applicant(s)/Patent Under Reexamination YACH ET AL.
	Examiner Lin, Shew-Fen	Art Unit 2166

SEARCHED

Class	Subclass	Date	Examiner
455	412.2 and associated text search	1/5/08	SFL
455	412.2 with text search	1/25/10	SFL
707	102	1/25/10	SFL
707	758	4/1/10	SFL
455	412.2 with text search	6/17/10	SFL
707	999.102, 758	6/17/10	SFL

SEARCH NOTES

Search Notes	Date	Examiner
East	8/3/07	SFL
NPL (google)	8/3/07	SFL
East	1/5/08, 1/8/08, 1/9/08	SFL
East text search	7/20/08	SFL
East text search	12/10/08	SFL
East text search	5/15/09	SFL
East text search	1/25/10	SFL
NPL (google, ACM, IEEE)	1/25/10	SFL
East text refresh search	4/1/10	SFL
East text refresh search	6/17/10	SFL
NPL (google, ACM, IEEE)	6/17/10	SFL

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner
455	412.2	1/25/10	SFL
707	104.1	1/25/10	SFL
455	412.2	4/1/10	SFL
707	999.102	4/1/10	SFL
707	781-784	4/1/10	SFL
455	412.2	6/17/10	SFL
707	999.102	6/17/10	SFL
707	781-784	6/17/10	SFL

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